



Application No. 09/654,315
Amendment filed June 24, 2003
Reply to Office Action of March 24, 2003

Attorney's Docket No.: 42390.P4222D2

#15
Amendt
Y. Koleso
7/15/03
Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Robert S. Chau et al.

Application No: 09/654,315

Filed: September 1, 2000

For: DEVICE STRUCTURE AND
METHOD FOR REDUCING
SILICIDE ENCROACHMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Conf. No.: 5699

Examiner: Tran, Thien F.

Art Unit: 2811

AMENDMENT

Dear Sir:

This is in response to the Office Action mailed March 24, 2003. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on June 24, 2003

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